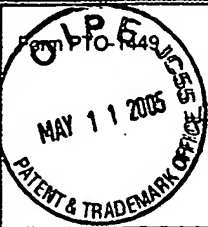


1125 5/11/2005

		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2358		SERIAL NO. 10/624,627	
		LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					
		APPLICANT: Luan C. Tran		FILING DATE July 21, 2003		GROUP 2812	

U.S. PATENT DOCUMENTS							
Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
Ju	AA	5,534,456	07/96	Yuan et al.			
Ju	AB	5,970,352	10/99	Shiozawa et al.			
Ju	AC	6,001,707	12/99	Lin et al.			
Ju	AD	6,420,749	07/02	Divakaran et al.			
Ju	AE	6,187,624	02/01	Huang			
Ju	AF	5,946,568	08/99	Hsiao et al.			
Ju	AG	6,242,329	06/01	Huster et al.			
Ju	AH	5,904,530	05/99	Shin			
Ju	AI	US2002/0006693	01/02	Matsuda			

FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
Ju	AJ	JP04105328A	04/92	Japan				
	AK							
	AL							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
Ju	AM		Wolf et al., <i>Silicon Processing for the VLSI Era</i> , Vol. 1: "Process Technology," Second Edition, Lattice Press 2000, pp. 12-13, 25-27.
Ju	AN		S.M. Sze, <i>VLSI Technology</i> , Second Edition, McGraw-Hill, 1988, pages 472-483
	AO		

EXAMINER	Jennifer M. Kennedy July 22, 2005
----------	-----------------------------------

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

PTO/SB/08A (07-05)

Approved for use through 07/31/2008. OMB 0851-0031
U.S. Patent and Trademark Office, U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Substitute for form 1449/PTO

Complete if Known

INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet 1

of 2

Application Number	10/824,627
Filing Date	07/21/2003
First Named Inventor	Luan C. Tran
Art Unit	2812
Examiner Name	J. Kennedy
Attorney Docket Number	MI22-2358

U. S. PATENT DOCUMENTS					
Examiner Initials*	Cite No.†	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code* (if known)			
<i>JK</i>		US- 5,532,107	7/1996	Ole et al.	
		US- 2001/0006752	7/2001	Watanabe et al.	
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			
		US-			

FOREIGN PATENT DOCUMENTS					
Examiner Initials*	Cite No.†	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear
		Country Code* Number* Kind Code* (if known)			

Examiner Signature <i>James M. Kennedy</i>	Date Considered <i>July 22, 2005</i>
--	--

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. Applicant's unique citation designation number (optional). † See Kind Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ‡ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). * For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. † Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.18 if possible. * Applicant is to place a check mark here if English language translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

If you need assistance in completing the form, call 1-800-PTO-9199 (1-800-786-9199) and select option 2.

PTO/SB/088 (08-03)

Approved for use through 07/31/2008. OMB 0651-0031
U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)		Complete If Known		
		Application Number	10/824,627	
		Filing Date	July 21, 2003	
		First Named Inventor	Luan C. Tran	
		Art Unit	2812	
		Examiner Name	J. Kennedy	
Sheet 2	2	of 2	Attorney Docket Number	MI22-2358

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
gu		Wolf et al., Silicon Processing for the VLSI Era, Volume 1-Process Technology, Second Edition, Lattice Press, 2000, pgs. 515-517.	
gu		Wolf et al., Silicon Processing for the VLSI Era, Volume 1-Process Technology, Second Edition, Lattice Press, 2000, pgs. 527-531.	

Examiner Signature	<i>J. Kennedy</i>	Date Considered	<i>July 22, 2005</i>
--------------------	-------------------	-----------------	----------------------

*EXAMINER: Initials // reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

If you need assistance in completing the form, call 1-800-PTO-9199 (1-800-786-9199) and select option 2.